



IPN

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q78969

Junji KOGURE, et al.

Appln. No.: 10/735,640

Group Art Unit: 2879

Confirmation No.: 3525

Examiner: Dalei Dong

Filed: December 16, 2003

For: METHOD OF MANUFACTURING A PLASMA DISPLAY PANEL BY  
DECOMPOSING IMPURITIES IN EXHAUST GAS WITH A CATALYST (as amended)

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 24, 2005, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE SPECIFICATION.....2

REMARKS .....3